## Notice of References Cited Application/Control No. 10/523,420 Examiner H. T. Le Applicant(s)/Patent Under Reexamination LEITE ET AL Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-4,107,376	08-1978	Ishikawa, Takashi	428/305.5
*	В	US-4,233,199	11-1980	Abolins et al.	524/139
*	С	US-4,254,177	03-1981	Fulmer, Glenn E.	428/305.5
*	D	US-5,721,281	02-1998	Blount, David H.	521/50
*	E	US-5,952,408	09-1999	Lee et al.	524/127
*	F	US-6,160,028	12-2000	Dyer, John Collins	521/64
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	к	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U					
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	x					

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